

9-22-03

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>	Docket Number (Optional) <b>COHD-5050</b>		Application Number <b>NEW</b>
	Applicant(s) <b>Serguei Anikitchev and R. Russel Austin</b>		
	Filing Date <b>HEREWITH</b>	Group Art Unit <b>Unknown</b>	

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
W	*AA	4,826,269	05/02/1989	Streifer et al.	350	3.72	10/16/1987
W	*AB	5,091,636	02/25/1992	Takada et al.	235	454	07/03/1991
W	*AC	5,504,317	04/02/1996	Takahashi	235	462	01/05/1994
W	*AD	5,517,359	05/14/1996	Gelbart	359	623	01/23/1995
W	*AE	5,521,748	05/28/1996	Sarraf	359	321	06/16/1994
W	*AF	5,710,418	01/20/1998	Tawara	235	472	11/03/1995
W	*AG	5,967,645	10/19/1999	Anderson	362	259	04/04/1996
W	*AH	5,969,872	10/19/1999	Ben Oren et al.	359	621	01/11/1999
W	*AI	6,494,371	12/02	Rekow et al.	235	454	
W	*AJ	4,497,015	01/85	Konno et al.	362	268	
W	*AK	4,619,508	10/86	Shibuya et al.	353	122	
W	*AL	6,431,727	08/02	Sugawara et al.	362	244	
W	*AM	6,411,440	06/02	Ohuchi et al.	359	621	
W	*AN	6,499,845	12/02	Sato	353	38	
W	*AO	6,505,957	01/03	Chuang	362	268	
W	*AP	5,594,526	01/97	Mori et al.	355	67	
W	*AQ	6,478,452	11/02	Richardson et al.	632	268	
W	*AR	5,610,763	03/97	Kudo	359	619	
W	*AS	6,421,178	07/02	Lissotschenko et al.	359	559	

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
W	AT	EP 0 886 162 A2	06/17/1998	EPC	G02B	27/09		

**OTHER DOCUMENTS**  
*(Including Author, Title, Date, Pertinent Pages, Etc.)*

W	AU	Principles of Optics Electromagnetic Theory of Propagation, Interference and Diffraction of Light, by Max Born & Emil Wolf, Pergamon Press, 6th Edition, 1980 (reprinted 1984), Chapter "10.5.2 The influence of the condenser on resolution in a microscope," pp. 522-525.
W	AW	U.S. Patent Application Publication No. US 2003/0128543 A1, published July 10, 2003, application no. 10/043,036, filed January 7, 2002, applicant: Mathew N. Rekow.

Examiner	James Vannucci	Date Considered	7-7-05
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			